IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Takayuki SAITO et al.

Attn: APPLICATION BRANCH

Serial No. NEW

Attorney Docket No. 2003 1585A

Filed October 30, 2003

THE COMMISSIONER IS AUTHORIZED

TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT

ACCOUNT NO. 23-0975

SUBSTRATE PROCESSING APPARATUS AND SUBSTRATE PROCESSING METHOD

COVER LETTER ACCOMPANYING APPLICATION FILED WITHOUT EXECUTED **DECLARATION UNDER 37 CFR 1.53(b) AND IN A LANGUAGE** OTHER THAN ENGLISH UNDER 37 CFR 1.52(d)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Enclosed is a new patent application entitled "SUBSTRATE PROCESSING APPARATUS AND SUBSTRATE PROCESSING METHOD". This application is submitted in the Japanese language under the provisions of 37 CFR 1.52(d).

Furthermore, the present application is submitted under the provisions of 37 CFR 1.53(b), and the application as filed does not include an executed declaration. However, accompanying the application is an unexecuted declaration listing the inventor information.

The application as filed further does not include an executed power of attorney, and accordingly, it is requested that communication initially be directed to the following firm, until an executed power of attorney and declaration are filed:

> WENDEROTH, LIND & PONACK, L.L.P. 2033 K Street, N.W., Suite 800 Washington, D.C. 20006-1021

> > Telephone: (202) 721-8200 Facsimile: (202) 721-8250

The required filing fee of \$770.00 is enclosed.

Respectfully submitted,

Takayuki SAITO et al.

By

Michael S. Huppert Registration No. 40,268 Attorney for Applicants

MSH/kjf Washington, D.C. 20006-1021 Telephone (202) 721-8200 Facsimile (202) 721-8250 October 30, 2003 Rev. 1-10-03 Effective March 1998

DECLARATION AND POWER OF ATTORNEY FOR U.S. PATENT APPLICATION

(X) Original	() Supplemental	() Substitute	() PCT	() DESIGN
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As a below named inventor, I hereby declare that: my residence, post office address and citizenship are as stated below next to my name; that I verily believe that I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural inventors are named below) of the subject matter which is claimed and for which a patent is sought on the invention entitled:

joint inventor (if plural inventors ar invention entitled:	e name	d below) of the subject matter wh	ich is cl	aimed and for which a p	patent is sought on the
Title: SUBSTRATE PROCESSING	APPA	RATUS AND SUBSTRATE PRO	CESSING	METHOD_	
of which is described and claimed in () the attached specification, or (X) the specification in application S, or	erial No				mendments through
() the specification in International A I hereby state that I have reviewed an any amendment(s) referred to above.					claims, as amended by
I acknowledge my duty to disclose t defined in Title 37, Code of Federal I			formation	known to me to be mate	erial to patentability as
I hereby claim priority benefits under for patent or inventor's certificate lis a filing date before that of the application.	ted belo	ow and have also identified below a			
COUNTRY		APPLICATION NO.	DA	ATE OF FILING	PRIORITY CLAIMED
Japan	·	2002-211524		July 19, 2002	YES
Japan		2002-213078		July 22, 2002	YES
I hereby claim the benefit under Titl subject matter of each of the claims of the first paragraph of Title 35, Unite defined in Title 37, Code of Federal or PCT international filing date of the	of this a ed State Regulat	application is not disclosed in the pes Code §112, I acknowledge the tions, §1.56 which occurred between	rior Unite duty to d	ed States application in this isclose information materials.	ne manner provided by crial to patentability as
APPLICATION SERIAL NO		U.S. FILING DATE		STATUS: PATENTE ABANDO	

And I hereby appoint Michael R. Davis, Reg. No. 25,134; Matthew M. Jacob, Reg. No. 25,154; Warren M. Cheek, Jr., Reg. No. 33,367; Nils Pedersen, Reg. No. 33,145; Charles R. Watts, Reg. No. 33,142; Michael S. Huppert, Reg. No. 40,268; and Jeffrey R. Filipek, Reg. No. 41,471, who together constitute the firm of WENDEROTH, LIND & PONACK, L.L.P., as well as any other attorneys and agents associated with Customer No. 000513, to prosecute this application and to transact all business in the U.S. Patent and Trademark Office connected therewith.

I hereby authorize the U.S. attorneys and agents named herein to accept and follow instructions from <u>WATANABE & HOTTA</u> as to any action to be taken in the U.S. Patent and Trademark Office regarding this application without direct communication between the U.S. attorneys and myself. In the event of a change in the persons from whom instructions may be taken, the U.S. attorneys named herein will be so notified by me.

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I further declare that all statements made herein of my own knowledge are true, and that all statements on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application or any patent issuing thereon.

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The above application may be more particularly identified as	follows:
U.S. Application Serial No Fili	ing Date October 30, 2003
Applicant Reference Number <u>GEB2005-US</u> Atty Docket N	o. <u>2003_1585A</u>

Title of Invention SUBSTRATE PROCESSING APPARATUS AND SUBSTRATE PROCESSING METHOD